

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/631,185	CHAUVEL ET AL.	
Examiner Arpan P. Savla		Art Unit 2185	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,687,336	11-1997	Shen et al.	712/202
*	B	US-5,893,121	04-1999	Ebrahim et al.	707/206
*	C	US-6,026,485	02-2000	O'Connor et al.	712/226
*	D	US-6,801,986	10-2004	Steely et al.	711/152
*	E	US-4,928,239	05-1990	Baum et al.	711/136
*	F	US-5,893,148	04-1999	Genduso et al.	711/132
*	G	US-6,151,661	11-2000	Adams et al.	711/132
*	H	US-6,209,061	03-2001	Nelson et al.	711/132
*	I	US-6,671,196	12-2003	Civlin, Jan	365/49
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	T. R. Haining, J.-F. Pâris and D. D. E. Long, "A Stack Model Based Replacement Policy for a Non-Volatile Write Cache", Proceedings of the 8th NASA Goddard Conference on Mass Storage Systems and Technologies, March 27-30, 2000, pp. 205-211
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.